

## THIN FILM COATINGS & OPTICS



# THE COMPANY



The HHV Group is India's premier thin film and vacuum technology group with almost 60 years of expertise in the design and manufacture of high vacuum equipment for research and industrial applications.

HHV Advanced Technologies (HHV AT) is a global developer of vacuum coating systems for optical, decorative and functional coatings, astronomical telescope mirror coaters and special purpose vacuum equipment.

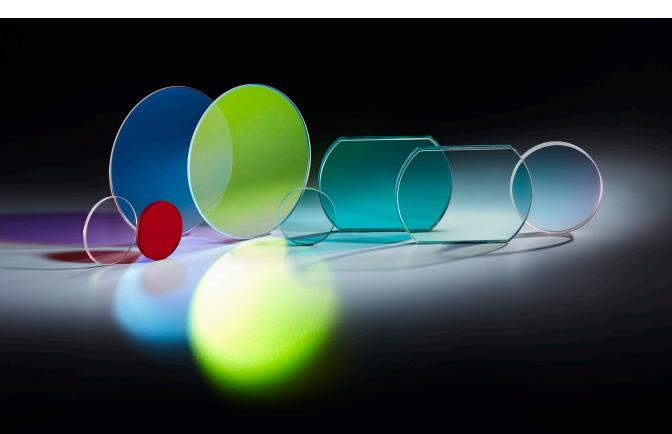
HHV AT is a leading manufacturer of high precision optical components and thin film coatings. Our products are integral to multiple sectors that include Aerospace, Automotive, Defense and Space.

HHV AT has multiple manufacturing facilities located in Bengaluru, India and offices located globally. HHV AT is an ISO 9001:2015, ISO 14001:2015 and ISO 45001 2018 certified company.

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## TECHNOLOGY & EXPERTISE

HHV AT provides end to end services from customized design to supplying the final product. The Thin Films and Optics Division has a wide range of technical coating and optics focused capabilities.

#### THIN FILM COATING

The Thin Films and Optics Division has a wide range of technical coating and optics capabilities such as:

- 1. Single and wide band Anti-Reflection coatings
- 2. High Reflective Metal and Dielectric coatings
- 3. Beam Splitter coatings
- 4. Transparent Conductive coatings
- 5. Short pass, Long pass, Band pass and Notch Filter coatings
- 6. Custom coatings based on customer requirements

We have numerous coating systems with the capability for coating a full range of optical coating materials. Our coating technologies include:

#### **DESIGN CAPABILITIES**

We utilize several software programs including Essential Macleod, TF-Calc and CODE to create coatings with the best possible design, optimisation, and sensitivity.

#### RESEARCH AND DEVELOPMENT TEAM

The Thin Film and Optics R&D team consists of scientists and engineers who are uniquely qualified to provide a variety of application integration services to customers by creating ideal solutions for thin film requirements. Our R&D team is equipped to develop products through our extensive design and manufacturing resources to create products that meet customer needs.

- 1. Magnetron Sputtering systems
- 2. Ion-Assisted E-Beam Deposition systems
- 3. Resistance Evaporation systems
- 4. Plasma Enhanced Chemical Vapour Deposition systems
- 5. Atomic Layer Deposition systems



#### PHOTOLITHOGRAPHY LAB

Our Photolithography Lab (PLL) develops Thin Film Metallized Circuits on alumina substrates.

The Photolithography Lab produces various types of circuits with multi-layers of metallization for different frequencies.

The Lab is is equipped with a laser writer for mask fabrication, UV exposure systems, an

etching room containing a chemical wet bench, dicing machines to cut the metallized substrates to required sizes and highperformance microscopes and profile projectors for inspection and measurement of the patterned substrates.

Our Photolithography Lab has ISO 7, ISO 8 clean rooms and class 100 laminar flow stations that allow us to achieve resolutions of up to 40 microns.



Clean Room

Metallization Lab



Inspection Lab

Photolithography Lab

#### PRECISION OPTICS FABRICATION LAB

The precision Optics Fabrication Lab (OFL) is equipped with state-of-the-art technology and machinery to fabricate high precision optical components for the visible and infrared spectrum.

We offer end to end solutions, from substrate manufacture to the thin film coated component, for complex optical system requirements, especially for space and defense departments.

We are equipped with high quality machines for slitting, trepanning, curve generation, grinding, polishing, centring and edging for spherical and aspherical optics.

Finished products go through rigorous quality checks with equipment such as Zygo interferometers with transmission spheres to measure surface figures up to 1/10th of

lambda, Davidson autocollimators to measure surface angles and parallelism to an accuracy of one arc second, and Trioptics spherometers to measure the radius of curvature of various components to an accuracy of one micron.

Our expertise comes from its superior thin film coating ability and knowledge of handling materials like fused silica, zerodur, optical glass for the visible spectrum and silicon, germanium, zinc sulphide, barium fluoride, calcium fluoride and lithium fluoride materials for the infrared spectrum.

We develop lenses, flats, prisms, aspherics and infra-red domes for applications including visible, night vision optics, binoculars, periscopes, astronomical telescopes and defense products.





Optics Fabrication Lab

We have has the capability to manufacture a wide variety of prisms with tight tolerances, accurate fringe control, and angle precision. We offer different types of prisms such as dispersion prisms, deflection or reflection prisms, rotating prisms and offset prisms.



#### SINGLE POINT DIAMOND TURNING

Our Single Point Diamond Turning (SPDT) ultra-precision machines fabricate crystalline infrared materials like Silicon and Germanium. Our SPDT systems are used to manufacture spherical and aspherical optical components.







Nanoform systems for Single Point Diamond Turning

#### QUALITY ASSURANCE

We have the ability to perform a wide range of quality tests to ensure products are compliant to customer standards. All our characterization equipment are tested, controlled, calibrated and maintained to meet the requirements of our Quality System.



Characterization Lab

### PRODUCTS

We produce high-quality, standard and custom designed thin film and optics products for a wide range of scientific, industrial, defense and space applications.

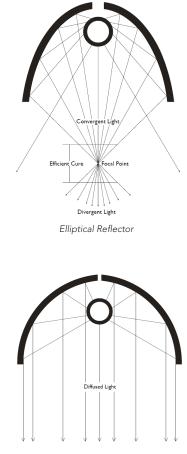
#### 1. UV REFLECTOR Glass & Aluminium

We are the world's largest manufacturer of UV reflectors. UV reflectors direct UV light on to substrates that are being cured. They play a critical role in UV curing systems by enhancing the efficiency of the curing process.

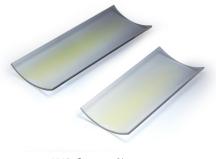
UV reflectors are widely used for flexographic printing where UV curable ink offers images with sharper colours and outputs that consume less energy. Label printing industries use UV reflectors to dry UV curable inks and varnishes. UV dichroic reflectors reflect UV radiation and transmit IR radiation, thus acting as a cold mirror, which significantly reduces the heating up of objects being cured.

Aluminium reflectors are used for low wattage applications, whereas as quartz glass reflectors are used for higher temperature applications.

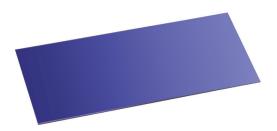
Our coatings ensure higher output and lower energy consumption and are available in spherical and elliptical profiles. Our coatings provide thermal stability up to 350 °C on glass and 250 °C on aluminium and ensure high reflectivity within the UV spectrum and high transmission and absorption for wavelengths in the visible and IR spectrum.



Parabolic Reflector



UV Reflectors : Glass



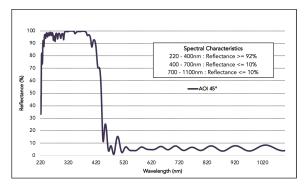
UV Reflectors : Aluminium

We provide end to end services from cutting and bending the substrate to coating and marking the reflectors.

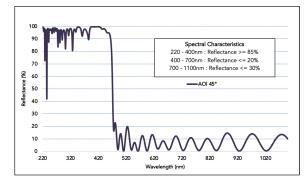
#### PRODUCT FEATURES

- Substrate: Borofloat Glass, Quartz, Stainless Steel, Aluminium
- Dimension: Lengths up to 1200 mm
- Durability: MIL-C-48497A
- Custom profiles and designs available upon request

- Drying and curing inks for label printing
- Adhesion reduction of semiconductor dicing tape
- Curing optically clear adhesives in LCD panels
- Curing varnishes and paints to process wood
- Curing conformal coatings on electronic components
- Curing adhesives for mobile phone components



Spectral Graph : Glass



Spectral Graph : Aluminium

#### 2. UV REFLECTOR Fibre Optics

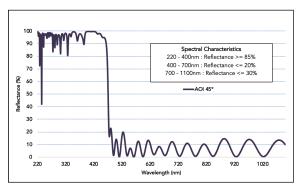
UV curing systems utilize UV reflectors to rapidly and evenly cure fibre optic cables, from core to clad, using high intensity light. Glass optical fibre is produced on a multistory drawing tower where a preform is heated and pulled to thin strands at high speeds. Fibres cured with UV radiation are especially resistant to abrasion and scratches at higher production speeds.

Our fibre optic reflector coatings are carried out through a thin film deposition technique that uses alternate layers of high and low index oxide layers.

The UV cured optical fibre coating is used to close notches that occur during pultrusion. It also prevents cracks and protects and strengthens the optical fibres.

UV paints are applied and cured on optical fibres for colour coding and marking. Vented reflectors are commonly used with microwave powered UV lamp systems that are required to filter ozone out of the system. Based on the configuration and placement of the reflector with respect to the UV lamp source, the reflector can be classified as front or back and act as a hot or cold mirror. End reflectors include a small hole for holding the UV bulb in the focus position for maximum peak irradiance. The reflectors have precisely shaped geometry to maximise UV light and can directly replace OEM products.

The coatings have high reflectance in the UVA, UVB and UVC regions with high absorbance of IR energy. Our reflectors are available with or without dichroic coatings.



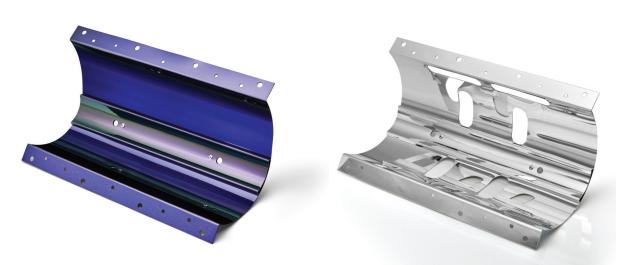
Spectral Graph : Fiber Optics

#### PRODUCT FEATURES

- Substrate: Aluminium
- Dimension: Lengths up to 1200mm
- Durability: MIL-C-48497A
- Custom profiles and designs available upon request

#### **APPLICATIONS**

- Curing of optical fibres for telecommunications
- Curing of inks on wire and cable products for colouring



UV Reflectors Fiber Optics

#### 3. IR BLOCKERS

Our IR blocker coatings are deposited on quartz glass substrates and selectively filter ultra-violet energy from the source, while blocking unwanted visible and infra-red energy. IR blockers are used in conjunction with UV reflectors, and the entire system acts as a UV filter. IR blockers are placed in front of a UV lamp source and function as a hot mirror, thus keeping the UV system cool by protecting heatsensitive materials, lamps and reflectors from ink evaporants. Our IR blocker coatings have thermal stability up to 400 °C and high transmission in the UV range.

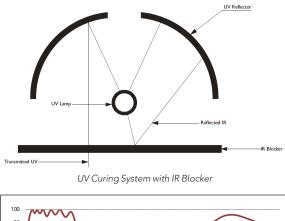
#### PRODUCT FEATURES

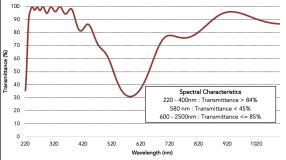
- Substrate: Quartz
- Dimension: Lengths up to 600 mm Thickness: 2 to 3 mm
- Durability: MIL-C-48497A

 Custom profiles and designs available upon request

#### APPLICATIONS

 UV curing systems for temperaturesensitive materials









IR Blocker

#### 4. RETICLES

Reticles are optics designed to insert into eyepieces of an imaging system that superimposes either a crosshair or concentric circle pattern on the imaged object. The reticle pattern provides a reference location and allows the imaged object to be centered. HHV AT has a complete lithography facility to make reticles with chrome patterns or etch and fill technology. HHV AT's facility is equipped with laser writers, etching stations, Laurell Spin coaters and SUSS MJB3 UV exposure systems. FEATURES

- Substrate: Borofloat, BK7, UVFS glass substrates
- Dimension: Diameter upto 50mm
- Patterns: Positive, negative crosshair, Concentric circles
- Line Resolution: 5± 2µ

#### APPLICATIONS

- Rifle scopes
- Range finders
- Surveillance instruments
- Optical encoders
- Stage micrometers



Reticles

#### 5. LASER SAFETY GLASSES

We continue to lead the way in technologically advanced laser safety glasses that adhere to international laser safety standards. Laser safety eyewear is designed to reduce hazardous laser eye exposure to safe and permissible levels by providing an optical density (OD) that attenuates the laser that is being used, while allowing enough visible light transmission (VLT) for comfortable visibility.

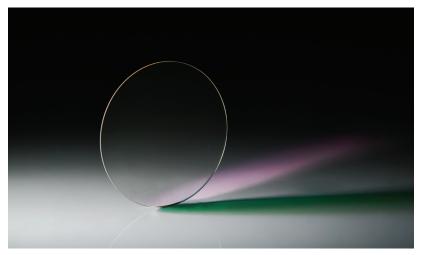
We offer the highest quality laser safety glasses with ODs suitable for most photonics applications. Our coatings cover visible to near-infrared wavelengths. HHV AT's thin film laser glasses have multilayer coatings with high ODs and VLT.

Our laser glasses offer safety against Class 3R, Class 3B and Class 4 lasers

#### PRODUCT FEATURES

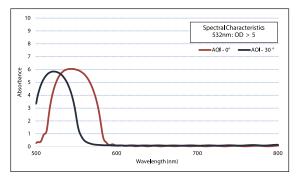
- Substrate: Borofloat, KG5
- Dimension: Diameter upto 230 mm
- Durability: MIL-C-675C
- Custom filters can be designed and produced upon request
- Optical Density: Upto OD 8+

- Laser safety eyewear in the medical industry
- Laser safety eyewear in the military

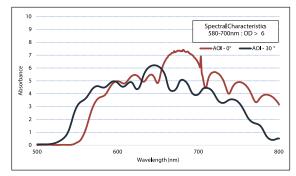


Laser Safety Glass

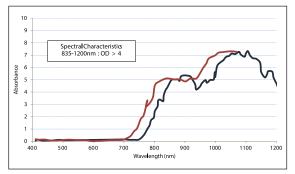
#### Spectral Graphs



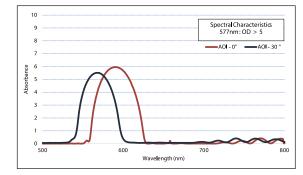
Laser Safety Glasses 532 nm



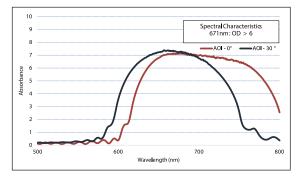
Laser Safety Glasses 580 - 700 nm



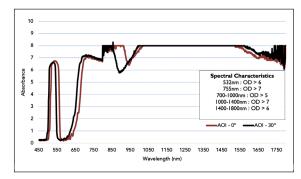
Laser Safety Glasses 835 - 1200 nm



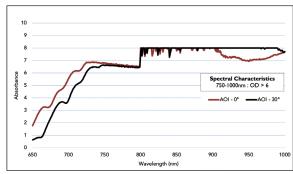




Laser Safety Glasses 671 nm







Laser Safety Glasses : 750 – 830 nm

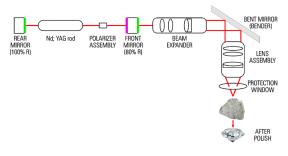
#### 6. LASER OPTICS

High reflective laser mirrors are used in laser resonators to increase the intensity of the beam. HHV AT's multilayer coatings ensure high reflection, durability and high Laser Induced Damage Thresholds (LIDT).

We have proven expertise in designing laser mirrors that offer high damage threshold. Beam steering mirrors are used outside the laser cavity and are used to fold the laser beam. These mirrors are mounted at a 45° angle to the beam direction.

Our laser mirror coatings are hard and durable, have achieved more than 99.95% reflectance and can withstand damage thresholds up to 20 J/cm2.

Our cavity laser mirrors for diamond cutting achieve more than 99.5% reflectance and can be used in laser cavities that are designed for single line, multi-line or broadband sources.

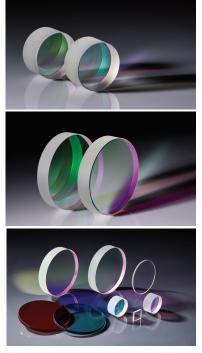


Diamond Laser Cutting setup

#### PRODUCT FEATURES

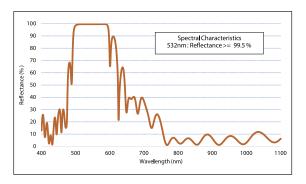
- Substrate: UVFS, Quartz, BK7
- Dimension: Diameter upto 230 mm
- Durability: MIL-C-675C
- Custom coating designs are available upon request

- Lasers for diamond cutting
- High reflection mirrors in laser gyros
- Industrial lasers for cutting
- Medical lasers for various operations

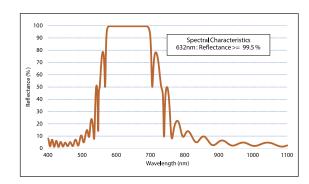


Laser optics

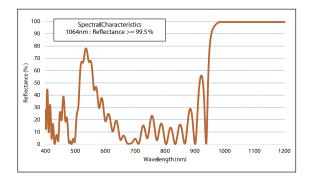
#### Spectral Graphs



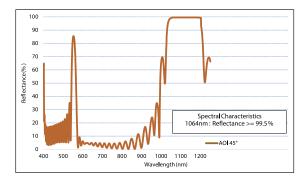
HR Mirror 532 nm



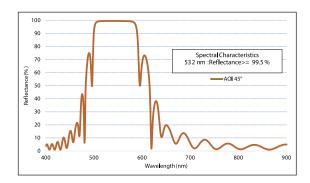
HR Mirror 632 nm



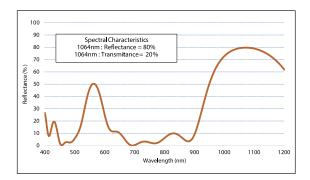
HR Mirror 1064 nm



Beam Bender 1064 nm



Beam Bender 532 nm



Output Coupler 1064 nm

#### 7. NIGHT VISION OPTICS

Night vision technology uses infrared radiation for imaging in a dark environment. The three main classes of night vision technology are NIR, low-light and thermal imaging. NIR imaging uses an infrared illuminator to provide grey-scale images. Low-light imaging uses an image intensifier tube to amplify available light.

Thermal imaging creates an electronic image from an object's heat signature. We offer a variety of coatings for Night Vision Devices (NVD) on silicon and germanium. For applications such as thermal windows, a high efficiency and high durability antireflection coating is coupled with a hard and adherent Diamond-Like Carbon (DLC) coating to provide superior properties in terms of transmission and hardness.

Our AR coatings contain no radioactive materials and have a high transmission in the MWIR band for Silicon and LWIR and MWIR bands for Germanium.

The DLC coatings possess high hardness and high transmission in the MWIR band for Silicon and LWIR and MWIR bands for Germanium.

#### PRODUCT FEATURES

- Substrate: Silicon, Germanium, Zinc Sulphide, Zinc Selenide and Chalcogenide Glass
- Dimension: Diameter up to 230mm
- Durability:
  - ARC: MIL-C-48497
  - DLC: MIL-C-48497A, TS-1888 (Windshield Wiper)
- Custom coating designs are available upon request
  - **APPLICATIONS**
- Thermal imaging
- Pyrometers

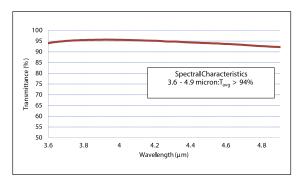


Diamond-Like Carbon

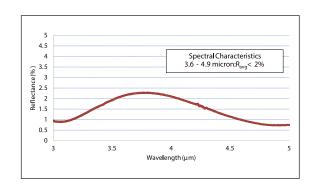


Night Vision Optics

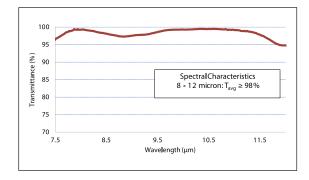
#### Spectral Graphs



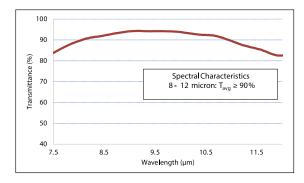
Transmission: HEAR (MWIR) on Silicon



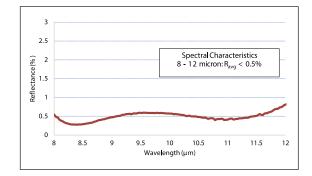
Reflection: HEAR (MWIR) on Silicon



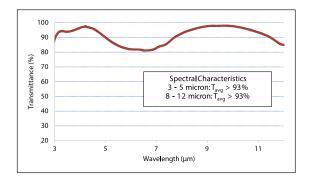
Transmission: HEAR (LWIR) on Germanium



Transmission: DLC + HEAR (LWIR) on Germanium



Reflection: HEAR (LWIR) on Germanium



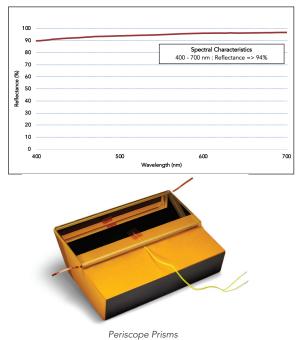
Transmission: Dual Band (MWIR & LWIR) ARC on Germanium

#### 8. PERISCOPE AND PRISMS

Periscope consists of ITO coated heater plate that is laminated with a prism through an autoclave process for sealing and encapsulation.

A periscope makes use of two triangular prisms to change the direction of light by 90°. The reflective portion of the prism consists of a silver coating that is deposited directly on the prism.

Our reflective coatings are finished with protective paint to prevent it from atmospheric degradation. The entire assembly is bullet-proof and chemically inert. Prisms can also be supplied on request.



#### PRODUCT FEATURES

- Substrate: Glass and PMMA
- Dimension: Lengths up to 300 mm
- Periscopicity: 225 max
- Total field of view, Horizontal up to 110° and Vertical up to: 30°
- Laser Safety protection is available
- Durability: Temperatures: -40 °C to +60 °C, Relative humidity of 95%
- Custom periscope can be designed and produced upon request

#### APPLICATIONS

- Periscopes in submarines for defense
- Periscopes in battle tanks for defense



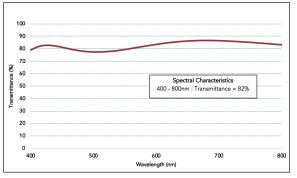
Periscope

#### 9. TRANSPARENT HEATERS

Transparent heaters are substrates coated with transparent and electrically conductive ITO coatings. Controlling the sheet resistance of the film and the resistance of the heating element allows us to control the attainable temperature of the heater. The shape or pattern of the resistor circuit can be fine-tuned for optimum performance.

Bus bars are provided at the edge of the heater for integration with an external power source. ITO coatings can be applied on glass, plastics such as acrylic and polycarbonate and flexible substrates such as PET and Kapton which are widely used in flat panel displays, scientific research and LCD / OLED manufacturing processes.

Additionally, ITO coatings can be indexmatched (IMITO) along with an antireflective coating to reduce reflectance at various interfaces. ITO glasses are laminated and autoclaved for higher strengths.



#### Spectral Graph : ITO Coating

#### PRODUCT FEATURES

- Substrate: BK 7, Borofloat, Polycarbonate, Acrylic
- Dimension: Lengths up to 300 mm
- Durability:
- Autoclaved heaters: -40 °C to +60 °C, Relative humidity of 95%
  - ITO Coatings on glass and plastic: MIL- STD-810F

Shapes, profiles and resistance can tailored to customer requirements

- Defogging windows
- Electronic devices
- LCD panels
- Cockpit displays
- Automobile windshields and headlights
- Slides for microscopes
- Camera security systems



Transparent Heaters

#### 10. THIN FILM METALLIZED CIRCUITS

Our thin film metallization process is carried out through magnetron sputtering.

The deposited metal layers show superior adhesion, structural and electrical properties in comparison to non-vacuum methods.

Metallization schemes that we offer:

TiW/Au or TaN/TiW/Au	TiW: 200 - 500 Å Au: 5 - 7 μm TaN: 10 - 250 Ω/□ if resistor layer is required
TiW/Au/NiV/Au	TīW: 200 - 500 Å Au: 3 - 3.5 μm NīV: 0.5 - 1 μm Au: 2 - 2.5 μm
Cr/Cu/Au	Cr: 200 - 800 Å Cu: 4 - 5 μm Au: 1.8 - 2 μm
Cr/Cu/Ni/Au	Cr: 200 - 800 Å Cu: 4 - 5 μm Ni: 0.1 - 0.5 μm Au: 1.8 - 2 μm
NiCr/Cu	NiCr: 200 Ω/□ Cu: 5 - 7 μm
NiCr/Ni/Au	NiCr: 200 Ω/□ Ni: 0.1 - 0.5 μm Au: 3 μm
TiW/Au or Cr/Au	Au: 0.5 - 7 µm TiW: 200 - 500 Å Cr: 200 - 800 Å

The metallization schemes start with a bonding layer of titanium-tungsten or chromium and a conductive layer of gold or copper on a ceramic substrate. For resistor applications we use tantalum-nitride (TaN) or nickel-chromium (NiCr) layers and for solderable applications nickel or copper is added to the metallization scheme. All the metal layers are deposited in a single cycle without breaking the vacuum process.

The sheet resistance of TaN, NiCr and SiCr layers can be tuned from few ohms per square to several kiloohms per square depending on the application.

Subsequent to the metallization, the substrates are patterned in an in-house photolithography facility. We use positive photo resist to produce mask plates, For patterning, the substrates are first coated with a negative photoresist through spin coating and baked.

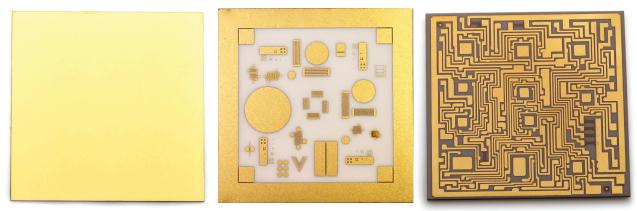
The patterns are generated using a mask aligner and UV exposure system.

The photoresist is then developed to realize the required pattern. With our in-house direct laser writing facility, we can achieve resolutions of 1 micron on photomasks and our lithography facility is capable of producing patterns with 10 micron linewidths.

#### PRODUCT FEATURES

- Substrate: Alumina, Zirconia
- Dimension: Up to 2\*2 inches
- Durability: Qualified for Space applications
- Custom patterns and metallization schemes can be developed and produced on request

- RF/Microwave integrated circuits
- Hybrid micro circuits
- SAW devices
- RADAR
- Thin film resistors
- Reticles



Thin Film Metallized Circuits

#### **11. SCAN MIRRORS**

In recent years, laser scanning has been used to identify the accurate distance between targets from combat vehicles. Laser beams are fired towards the target and the intensity/time of flight of the reflected beams are measured.

Laser scanners are silver coated mirrors, which rotate at certain angles to position the laser beams onto the target. It should possess lightweight and stiffness.

The critical requirements are lightweight, stiffness, strength and higher reflectivity in the required wavelength. A clock records the time of firing and receiving pulse. With the time data, the distance is calculated, and the target can be fired.

#### PRODUCT FEATURES

- $\lambda/4$  flatness
- Glass sealed airtight with 10 mm thick metal case.
- >96% reflectance in 400-1100 nm with silver coating
- Lightweight
- Dimension of mirror is 115 x 82mm

#### APPLICATIONS

Thermal imaging unit of fire control systems in military tanks.

he target can be fired.

Scan Mirror

#### 12. EMI SHIELDING COATINGS

EMI shielding coatings used are eliminate interference of to stray electromagnetic rays that can damage sensitive devices and components. Both metallic and transparent coatings can be used for EMI shielding. Commonly used metallic coatings include aluminium, copper and nickel.

We specialize in offering EMI shielding coatings on metallized plastic enclosures with complex geometries and can also custom make the coatings based on the required frequency and shielding effectiveness.

We also offer transparent EMI shielding coatings on glass and plastic substrates by depositing transparent conducting oxides such as ITO or AZO films that have high transmission in the visible range. Shielding effectiveness of our metallic EMI shielding coating is better than 80 dB for frequencies up to 1 GHz.

Shielding effectiveness of our ITO coatings are in the range of 50 to 60 dB. Indexmatched ITO (IMITO) coatings can also be developed for enhanced transmission.

#### PRODUCT FEATURES

- Substrate: Glass, Plastic
- Dimension: Lengths up to 1000 mm
- Durability: MIL-STD-810F
- Custom requirements for resistance and coating thickness upon request

- Smoke and fire sensors for industrial purposes
- Communication equipment and display devices for defense
- Ultrasound sensors for medical equipment
- Cockpit windshield for Aerospace



EMI Shielding Coating

#### 13. AR COATED ZINC SULPHIDE

Zinc Sulphide is used for missile seekers and windows due to its broadband optical transparency.

Zinc Sulphide (ZnS) domes are used as impact sensors on seeker missiles. When the missile makes contact with the target, the impact sensor sets off the warhead.

We have in-house facilities to fabricate ZnS. Substrates can be coated with high durability anti-reflection coatings suitable for the LWIR and MWIR regions with transmittance of more than 92%.

Our coatings on domes and windows are corrosion resistant, have excellent adhesion and if needed coated with a gold band to ensure a resistance of less than  $12\Omega$ .

#### PRODUCT FEATURES

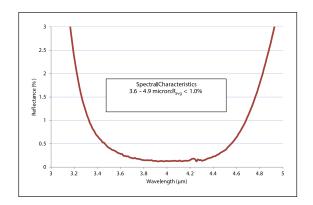
- Substrate: Zinc Sulphide
- Dimension: Diameter up to 230 mm
- Durability: MIL-C-675, TS-1888 wiper test
- Custom profiles can be generated upon request

- Seeker missiles for defense
- Front window in thermal imaging system

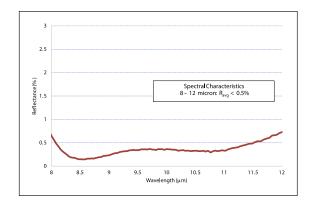


AR Coated Zinc Sulphide Domes

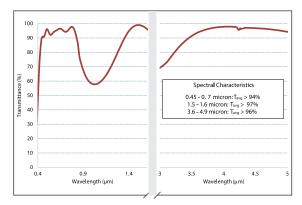
#### Spectral Graphs



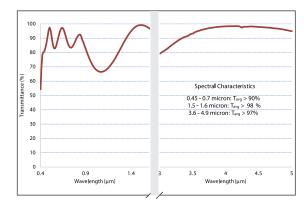
Reflection: HEAR (MWIR) on ZnS



Reflection: HEAR (LWIR) on ZnS



Transmission: Triple Band HDAR on ZnS



Transmission: Triple Band, extremely durable anti reflection coating (EDAR) on ZnS

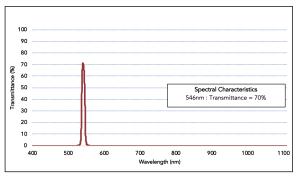
#### 14. OPTICAL FILTERS

An optical filter is a device which selectively transmits light of a specific wavelength. We offer a broad range of optical coatings that span the UV, visible and IR spectrum.

We produce fluorescence filters, narrow band interference filters, flame photometry filters, neutral density filters, short pass filters, long pass filters, band pass filters, notch filters, edge filters and coloured glasses.

The filters are coated with dielectric coatings and can be tailored to transmission and optical density requirements. HHV AT's optical filters offer superior hardness and durability.

Our filter coatings can be deposited on a single substrate or multiple substrates and laminated with optical cement to form a single element.



Spectral Graph : Optical Filters

#### PRODUCT FEATURES

- Substrates: BK7, Borofloat, UV Fused Silica, Quartz
- Filters are available in standard wavelengths of 340 nm, 405 nm, 450 nm, 492 nm, 505 nm, 546 nm, 578nm, 630 nm and 700 nm
- Dimension: Diameter up to 25mm
- Durability: MIL-STD-810E
- Custom wavelengths can be developed and produced on request

#### APPLICATIONS

- Determination of Sodium and Potassium levels in body fluids
- Determination of Calcium in milk, beer, fruit juice and biological fluids
- Determination of potassium in soil, fertilizers and plant-derived resins
- Fluorescence microscopy
- Biomedical instrumentation
- Lasers



**Optical Filters** 

## CONSUMABLES

We offer a wide variety of thin film deposition materials and consumables for high vacuum purposes.

#### **OPTICAL WINDOWS**

#### SPUTTERING TARGETS

Metals	Al, C, Cr, Cu, Ge, Co, Au, Hf, In, Fe, Pd, Mg, Mo, Ni, Nb, Pt
wetais	Se, Si (multi and mono), Ag, Ta, Ti, Sn, W, Zn, Zr, V
Oxides	Al2O3, CeO2, Cr2O3, CuO, Ga2O3, GeO2, In2O3, La2O3
Oxides	MgO, MnO2, Nb2O3, SiO2, Ta2O5, TiO2, WO3, ZnO
TCO	ITO (In2O3 : SnO2), AZO (ZnO : Al2O3)
тсо	GZO (ZnO : Ga2O3), IGZO (In : Ga : ZnO)
Other	Carbides, Fluorides, Nitrides
Other	Alloy, Ag Alloy, Al Alloy, Co Alloy, Cr Alloy, Ni Alloy, Ti Alloy
Forms	Circular (2-12 inches), Rectangular, Cylindrical rotary, Custom designs



#### **EVAPORATION MATERIALS**

Metal	Al, Au, Pt, Pd, Ag, Ru
Oxides	Al2O3, CeO2, Gd2O3, HfO2, ITO, MgO, Sc2O3, ZrO2,
Oxides	TiO2, TaO5, SiO, SiO2, Ta2O5, TiO, Ti2O3, Ti3O5, Y2O3
Fluorides	AIF3, BaF2, CaF2, CeF3, NaAIF6, LaF3, PbF3, MgF2,
Fluondes	PrF3, YF3
Sulphides and	ZnS, ZnSe
Selenides	zns, znse
Forms	Pieces, Granules, Powder, Rods, Wires, Sheets, Slugs,
Forms	Pellets, Nano powder, Ingots, Custom combinations



#### LINER, FILAMENTS AND BOATS

Material	W, Mo, Cu, C, Al2O3, BN, Quartz
Crucible Sizes	4сс, 7сс, 15сс, 25сс, 40сс
Equipment	All major manufacturers
manufacturers	All major manufacturers





#### QUARTZ CRYSTALS



## CERTIFICATIONS

We are an ISO certified company. HHV AT is also qualified by the Space Applications Centre for its metallization process. Our laser optics are certified by international testing agencies for laser damage.



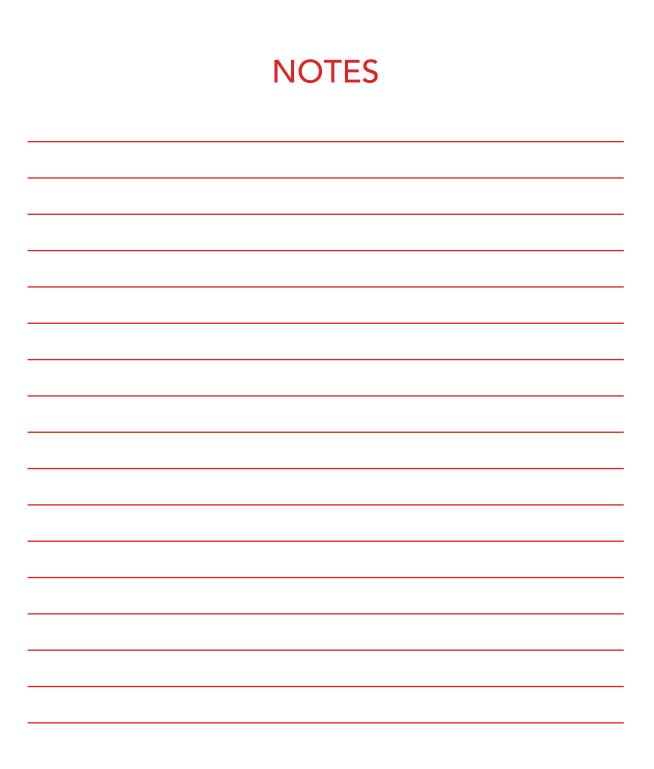
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operates a management system in act for conformity within the 3 year term of	contance with the requirem I validity of the certificate.	ents of ISO 9001:2015 and will be assessed	
Scope -			
Thin Film Deposition a	nd Photovoltaic ly of Optics and	Thin Film Coated Product	
Certificate Registration No.44 100 Audit Report No 2.5-10370/2021	21393259	Valid from 10.07.2021 Valid until 09.07.2024	
Tacayo			
Certification Body at TÜV NORD CERT GmbH		Mumbei, 10.07.2021	
TÜV NORD CERT GmbH	Langemarckatrasse	20 45141 Essen	ww.lutv.nord.ont.o
TUV India Pvt. Ltd., 801, Raheja Pl	sza - 1, L.B.S. Marg.	Ghatkopar (W). Mumbai - 400 086, India	www.huv-nord.com/in

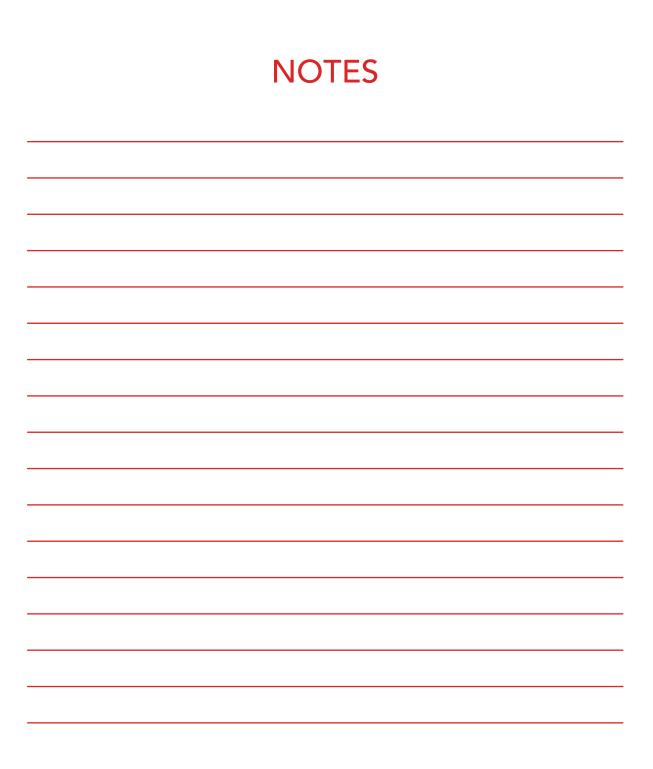


#### ISO Certificates

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अहमदाबाद – ३८+०१५ गुजरात, भारत	अर्हता प्रमाणपत्र /Certificate of Qualification	Ahmedabad – 380015 Gujarat, India	
जारी करने की तिथि: जयती १६.३०१७ प्रमतणपत्र सं.: जेवरण्यप्रात्त्रीविविद्यन्तरक्षत्र जारी करते : वेवरण्डव्यूत्रीन्त्रप्रस्त्रात्मेक		- ISSUE DATE: February 16, 2017 CERTIFICATE No: SAC/SRG/CERT/2017/03 ISSUED BY:: PMQD-E/SRG/SAC	
	This is to certify that M/s. Hind High Vacuum Company Private Limited	d	
ite No. 17, Phase 1, Peenya Industrial Area, 2 Samil thick alumina substrate in accordan	Bangalore -560058, India has been Qualified by Space Applicatio ce with ISRO-PAX-305, for Flight Hardware Realization. Details	ons Centre for 3- layer (Cr-Cu-Au) metallization process	
Sr. No. Process	уре С	Capabilitics	
1 3- layer metallization process substrate using Magnetron Sp	on 25 mil thick alumina Metallization: Cr-Cu-Au Sputter Chromium: 200-300 A <sup>o</sup> Sputter Copper 4-5 Microns Sputter Cold: 1.8-2 Microns		
यह प्रमाणप	त्र फरवरी १५, २०२० लक वैध है । This Certificate is valid up to	o February 15, 2020.	
<ul> <li>प्रक्रिया पहचान दस्तावेज सं.: HHV, HHV/TFD/MSS/SAC/CCA/05/</li> </ul>	//QTR/1.0, 2017 / Qualification Test Report No. SAC/SRG TFD/MSS/SAC/CCA/05/October, 2016 Process Identifi October, 2016		LASER DAMAGE CERTIFICATION PASS 944:1 WW/em <sup>2</sup> or 20.9 June <sup>2</sup>
र मुहेरेगरे (र. क्. हेगड़े)	भूभगभूवर्ट्स (क. बी. व्यास) (क. काल)	(तपन मिश्रा) (Tapan Misra)	Customer: Hind High Vacuum Co. Certificate No.: 171646 #1 Purchase Order No: PTFD/201616/0721 Issued: 4/14/2017
	(K. B. Vyas)         (A. K. Lal)           प्रधान, एसआरजीरसेक oup Head, SRG/SAC         युष निदेशक, एसआरजीरसेक Group Director, SRG/SAC	(1 apan Misra) निदेशक, सेक Director, SAC	Substrate Material: UV FS Coating Type: Ion assisted
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Space Qualification for Lithography







Thin Film Equipment | Precision Optics

#### CONTACT US FOR YOUR THIN FILMS AND OPTICS NEEDS TODAY

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